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TOWNSEND and TOWNSEND and CREW LLP

By


Kimberly Badiei

PATENT
Attorney Docket No.: 18062L-000100
UC Ref. No.: B98-020

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

PETER S. SIMPSON et al.

Serial No.: 08/965,738

Filed: November 7, 1997

For: MICROFABRICATED
CAPILLARY ELECTROPHORESIS
DEVICE AND METHOD

Examiner: BEISNER, W.

Art Unit: 1744

Batch No.: L75

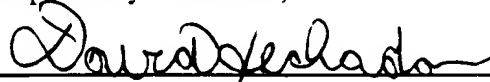
COMMUNICATION TRANSMITTING
REVOCATION AND SUBSTITUTE OF
ATTORNEY

Box Issue Fee
Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

Enclosed please find a REVOCATION & SUBSTITUTION OF ATTORNEY for the above-identified patent application.

Respectfully submitted,



David R. Heckadon

David R. Heckadon

(Granted Limited Recognition under 37 CFR §10.9(b) –
see enclosed Limited Recognition Document)

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On JUNE, 2000

TOWNSEND and TOWNSEND and CREW LLP

By:

NANCY A. PIZZO

PATENT

Attorney Docket No.: 18062L-000100

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

PETER C. SIMPSON et al.

Application No.: 08/965,738

Filed: November 7, 1997

For: MICROFABRICATED CAPILLARY ARRAY
ELECTROPHORESIS DEVICE & METHOD

Examiner: BEISNER, W.

Art Unit: 1744

**REVOCATION & SUBSTITUTION
OF ATTORNEY**

Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

Pursuant to 37 C.F.R. § 1.36, UCB Office of Technology Licensing ~~revokes~~ all previous powers of attorney and hereby appoints the following to prosecute this application and transact all business in the Patent and Trademark Office connected therewith:

David R. Heckadon

Granted Limited Recognition under 37
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Mark D. Barrish,

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Date: MAY 30, 2000

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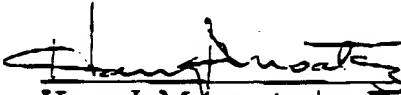
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BEFORE THE OFFICE OF ENROLLMENT AND DISCIPLINE**

LIMITED RECOGNITION UNDER 37 CFR §10.9(b)

David R. Heckadon is hereby given limited recognition under 37 CFR §10.9(b), as an employee of the Townsend and Townsend and Crew, law firm, to prepare and prosecute patent applications and to represent patent applicants wherein the patent applicants are clients of the Townsend and Townsend and Crew law firm, and wherein a registered practitioner who is a member of the Townsend and Townsend and Crew law firm is the attorney or agent of record. This limited recognition shall expire on the date appearing below, or when whichever of the following events first occurs prior to the date appearing below: (i) David R. Heckadon ceases to lawfully reside in the United States; (ii) David R. Heckadon's employment with the Townsend and Townsend and Crew law firm ceases or is terminated; or (iii) David R. Heckadon ceases to remain or reside in the United States on an H-1B visa.

This document constitutes proof of such recognition. The original of this document is on file in the Office of Enrollment and Discipline of the U.S. Patent and Trademark Office.

Expires: November 23, 2000


Harry I. Moatz, Acting Director
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